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Bib Data Sheet

CONFIRMATION NO. 1681

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|--|---|-------------------------------|---|--|--------------------------------|
| SERIAL NUMBER 09/910,110 | FILING DATE 07/20/2001 RULE | CLASS 029 | GROUP ART UNIT 3729 | ATTORNEY DOCKET NO. 1864 P 071 | |
| APPLICANTS Peter V. Loeppert, Hoffman Estates, IL; Sung Bok Lee, Chicago, IL; | | | | | |
| ** CONTINUING DATA ***** <i>NONE</i> | | | | | |
| ** FOREIGN APPLICATIONS ***** <i>NONE</i> | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/06/2001 | | | | | |
| Foreign Priority claims: <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met: <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged: <i>[Signature]</i> | | STATE OR COUNTRY IL | SHEETS DRAWING 3 | TOTAL CLAIMS 20 | INDEPENDENT CLAIMS 3 |
| ADDRESS Thomas K. Stine Wallenstein & Wagner, Ltd. 53rd Floor 311 South Wacker Drive Chicago, IL 60606-6630 | | | | | |
| TITLE Raised microstructure of silicon based device | | | | | |
| FILING FEE RECEIVED 710 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |